

Electronic Patent Application Fee Transmittal

Application Number:	10579777			
Filing Date:	26-Feb-2008			
Title of Invention:	Plasma Film-Forming Apparatus and Plasma Film-Forming Method			
First Named Inventor/Applicant Name:	Hiraku Ishikawa			
Filer:	Asaf Batelman/Cindy Edwards			
Attorney Docket Number:	101994.57726US			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	130	130

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				940